Direct Visualization of the Grain Boundary Solute Segregation in Oxide Material at Atomic Resolution Using STEM-EDS

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Grain boundaries usually govern the macroscopic properties of polycrystalline materials in practical use. Grain boundary segregation is a fundamental yet critical issue in this field since it affects the local structure and chemistry. Although the advanced aberration-corrected scanning transmission electron microscopy (STEM) has provided deep insights into such complex phenomenon even down to the atomic dimensions [1], most of these studies have been focused on the non-solute segregation. For this sort of segregation, the dopant atoms can only reside at grain boundaries and thus the experimental identification is straightforward [2]. On the other hand, for solute segregation, in which the dopant atoms can reside both at the grain interiors and grain boundaries, it is still challenging to clarify such phenomenon from experiment especially at atomic resolution.

Y segregation in yttria-stabilized zirconia (YSZ) grain boundary is a typical example of grain boundary solute segregation. Such local chemical inhomogeneity has been recognized as the origin of the high grain-boundary resistivity in ionic conductivity [3]. Probing the grain boundary solute segregation at atomic scale is therefore critical for a basic understanding of the chemistry at such interfaces, which in turn will provide new strategies for the design of high performance materials. Here, the local Y distributions near YSZ grain boundaries were directly determined by atomic-resolution elemental mapping using STEM energy-dispersive X-ray spectroscopy (EDS), equipped with a high-sensitivity silicon drift detector (SDD).

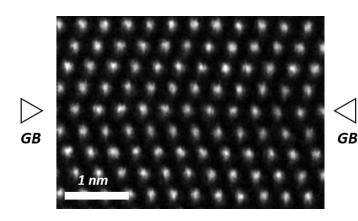
In this study, we selected $\Sigma3$ [110]/(111) YSZ grain boundary as a model grain boundary. YSZ (10 mol% Y₂O₃ doped ZrO₂) bicrystal containing a $\Sigma3$ [110]/(111) model GB was first fabricated by diffusion bonding of two single crystals at 1600 degree for 15 h [2]. EDS mapping was performed using a JEOL JEM-ARM200CF cold FEG. The accelerating voltage was 200 kV. The probe size is about 1.2 Å with the probe current of about 60 pA. The STEM-EDS system is equipped with double SDD-EDS detectors and the solid angle for the whole collection system is about 1.7 sr. Element maps were extracted with Zr K line (K_a of 15.776 keV and K_β of 17.668 keV) and Y K line (K_a of 14.958 keV and K_β of 16.738 keV).

Figure 1 is a high angular annular dark-field (HAADF) STEM image of the $\Sigma3$ [110]/(111) grain boundary (indicated by an arrow) from [110] direction. The grain boundary was bonded well at atomic level without any amorphous or secondary phase. Since the atomic column intensity in HAADF STEM image is approximately proportional to the Z² (where Z is the atomic number), the bright contrast represent the cation columns intermixed by Zr (Zr=40) and Y (Y=39). However, it is impossible to differentiate Y from Zr atoms from the HAADF STEM image contrast. Hereafter, STEM-EDS mappings were performed at the grain boundary. Figure 2 is the EDS profile obtained from the whole STEM EDS map. Figure 3a and d show atomic-resolution STEM-EDS mapping for Zr and Y, respectively. It can be seen that Y solute atoms strongly segregate in the two layers adjacent to the grain boundary mirror plane. Meanwhile, the Zr intensities in these two layers are decreased. Our further analysis show that a characteristic ordered segregation occurred, and such segregation structure is energetically favorable [4]. Details will be given in the presentation. [5]

References

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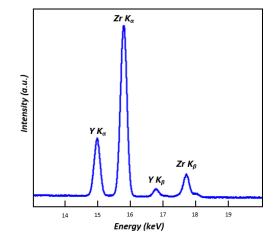
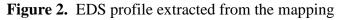


Figure 1. HAADF-STEM image of the Σ 3 grain boundary



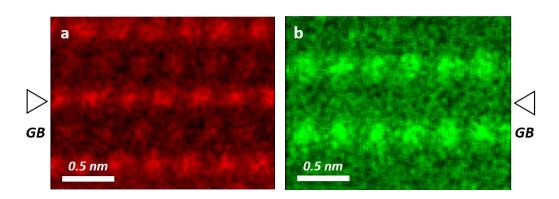


Figure 3. Atomic resolution STEM EDS maps at the grain boundary. (a) Zr map and (b) Y map.